

United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address COMMISSIONER FOR PATENTS P.O. Box 1450 Aksondria, Vegina 22013-1450 www.mpta.gov

Rib Data Sheet

CONFIRMATION NO. 3558

SERIAL NUMBER 10/757,202		FILING DATE 01/14/2004 RULE	(CLASS 438			JP ART UNIT 1765		ATTORNEY DOCKET NO. 2002- 0350/24061.484	
APPLICANTS										
Tung-Ching Tseng, Taipei City, TAIWAN;										
Syun-Ming Jang, Hsin-Chu, TAIWAN; Li-Jia Yang, Tainan City, TAIWAN;Chuan-Ping Hou, Yongkang City, TAIWAN;										
CONTINUING DATA										
FOREIGN APPLICATIONS										
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 04/19/2004										
Foreign Priority claimed yes one no SUSC 119 (a-d) conditions yes one one of the priority yes of the priority yes one of the priority yes one of the priority yes one of the priority yes of the priority yes one of the priority yes of t				STATE OR	SHEETS TO		тот	AL.	INDEPENDENT	
met Allowance Verified and Acknowledged Examiner's Signature		Allowance (1)	ials	COUNTRY TAIWAN	DRAWING 2		CLAIMS 19		CLAIMS 3	
ADDRESS 42717 HAYNES AND BOONE, LLP 901 MAIN STREET, SUITE 3100 DALLAS , TX 75202										
TITLE Method for chemical mechanical polishing of a shallow trench isolation structure										
	☐ All Fees									
FILING FEE	EES	ES: Authority has been given in Paper					☐ 1.16 Fees (Filing)			
RECEIVED 770	40. —	to charge/credit DEPOSIT ACCOUNT for following:				1.17 Fees (Processing Ext. of time)				
						1.18 Fees (Issue)				